



Docket No.: 543822004600  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Jens STACKER

Application No.: 10/816,184

Confirmation No.: 7855

Filed: April 2, 2004

Art Unit: 2877

For: METHOD AND APPARATUS FOR  
ORIENTING SEMICONDUCTOR WAFERS IN  
SEMICONDUCTOR FABRICATION

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Examiner: J. C. Underwood

**AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

This is in response to the non-final Office Action dated October 2, 2006 (Paper No. 20060912), for which a response was due on January 2, 2007. Filed herewith is a Petition and fee for a one-month extension of time, thereby extending the deadline for response to February 2, 2007. Accordingly, this response is timely filed. Reconsideration and allowance of the pending claims, as amended, in light of the remarks presented herein are respectfully requested.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.